<u>, </u>	A 11 41 - A1	A
Notice of Allowability	Application No.	Applicant(s)
	10/607,353	BROYLES ET AL.
	Examiner	Art Unit
	David L. Hogans	2813
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apply or other appropriate communication IGHTS. This application is subject to and MPEP 1308.	olication. If not included will be mailed in due course. THIS withdrawal from issue at the initiative
2. ☑ The allowed claim(s) is/are <u>1-6</u> .		
3. The drawings filed on June 26, 2003, are accepted by the	Examiner.	
 4. Acknowledgment is made of a claim for foreign priority ur a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	e been received. e been received in Application No	
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply MENT of this application.	complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
6. CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date(b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in to 7. DEPOSIT OF and/or INFORMATION about the depo	son's Patent Drawing Review (PTO s Amendment / Comment or in the C .84(c)) should be written on the drawing the header according to 37 CFR 1.121(c)	Office action of ngs in the front (not the back) of d).
attached Examiner's comment regarding REQUIREMENT	FOR THE DEPOSIT OF BIOLOGIC.	AL MATERIAL.
Attachment(s)	E T Nation of the control of the	Detant Application (DTO 450)
1. Notice of References Cited (PTO-892)	5. ☐ Notice of Informal P6. ☐ Interview Summary	Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	Paper No./Mail Dat	te
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0		ment/Comment
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's Stateme	ent of Reasons for Allowance
of Biological Material	SUPERVISORY	HITEHEAD, JR. PATENT EXAMINEE CY CENTER 2800

Art Unit: 2813

DETAILED ACTION

This Office Action is in response to the Transmittal of New Application filed on June 26, 2003.

Status of Claims

Claims 1-6 are pending.

Priority

1. This application appears to be a division of Application No. 10/140,536, filed May 7, 2002. A later application for a distinct or independent invention, carved out of a pending application and disclosing and claiming only subject matter disclosed in an earlier or parent application is known as a divisional application or "division." The divisional application should set forth the portion of the earlier disclosure that is germane to the invention as claimed in the divisional application.

Allowable Subject Matter

- 2. Claims 1-6 are allowed.
- 3. The following is an examiner's statement of reasons for allowance.

The prior art of record fails to teach or suggest, in combination with the other claimed features, first and second movable surface water vapor condensation traps that accumulate byproduct water vapor on first or second cooled surfaces of the movable water vapor condensation traps interior to a wafer processing chamber.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably

Art Unit: 2813

accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

US 5,426,865 to Ikeda et al. teaches placing a cooling plate in a load lock chamber to cold trap water vapor but fails to teach first and second movable surface water vapor condensation traps that accumulate byproduct water vapor on first or second cooled surfaces of the movable water vapor condensation traps interior to a wafer processing chamber.

US 5,582,017 to Noji et al. teaches a cold trap within a chamber for condensing water vapor but fails to teach first and second movable surface water vapor condensation traps that accumulate byproduct water vapor on first or second cooled surfaces of the movable water vapor condensation traps interior to a wafer processing chamber.

US 2002/0056311 to Nomura et al. teaches a vapor trap with movable trap units that are regenerated but fails to teach first and second movable surface water vapor condensation traps that accumulate byproduct water vapor on first or second cooled surfaces of the movable water vapor condensation traps interior to a wafer processing chamber.

Application/Control Number: 10/607,353

Art Unit: 2813

Any inquiry concerning this communication or earlier communications from the examiner should be directed to David L. Hogans whose telephone number is (571) 272-1691. The examiner can normally be reached on M-F (7:30-4:30).

Page 4

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead Jr. can be reached on (571) 272-1702. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

DH